In the Claims:

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substrate.

This listing of claims will replace all prior versions, and listing, of claims in the application:

(Currently Amended) A digital image sensor, comprising: 1. a first two-color photo-detector having a first photo-detector element eapable of designed for absorbing blue light within a first range of wavelengths and a second photodetector element capable of designed for absorbing complement of blue light within a second range of wavelengths, said first photo-detector element being in an elevated relation with said second photo-detector element, said first photo-detector element being electrically isolated from said second photo-detector element; and a second two-color photo-detector having a third photo-detector element eapable of designed for absorbing complement of red light within a third range of wavelengths and a fourth photo-detector element eapable of designed for absorbing red light within a fourth range of wavelengths, said first, second, third and fourth range of wavelengths each being different from the other, said third photo-detector element being in an elevated relation with said fourth photo-detector element, said third photo-detector element being electrically isolated from said fourth photo-detector element. 2. (Original) The sensor of Claim 1, further comprising: a substrate, said second photo-detector element being formed within said

1	3.	(Original)	The sensor of Claim 2, further comprising:			
2		a dielectric la	yer between said first photo-detector element and said second			
3	photo-detecto	photo-detector element, said dielectric layer electrically isolating said first photo-detector				
4	element from	said second pl	noto-detector element.			
1	4.	(Currently A	mended) The sensor of Claim 1, wherein said first photo-detector			
2	element is formed of amorphous silicon having a thickness selected to absorb said blue light					
3	within said first range of wavelengths and pass said complement of blue light within said					
4	second range of wavelengths, said second photo-detector detecting light within said second					
5	range of wavelengths passed by said first photo-detector element.					
	_					
1	5.	(Original)	The sensor of Claim 1, wherein said first and second photo-			
2	detector elements are photodiodes.					
1	6.	(Original)	The sensor of Claim 5, wherein said photodiodes are PIN			
2	photodiodes.					
1	7.	(Currently A	mended) The sensor of Claim 1, further comprising:			
2		a color filter	in an elevated relation with said first photo-detector element, said			
3	color filter absorbing light within another a portion of said complement of blue light range of					
4	wavelengths and passing the rest of said complement of blue light within said first and					
5	second ranges of wavelengths.					

1	8. ((Original)	The sensor of Claim 7, further comprising:		
2	а	a transparent n	netal conductor layer between said color filter and said first		
3	photo-detector element.				
1	9. ((Original)	The sensor of Claim 1, further comprising:		
2	C	circuitry for di	riving said first photo-detector element and said second photo-		
3	detector element, said first photo-detector element being in an elevated relation with said				
4	circuitry.				
1	10-12. ((Canceled)			
1	13. ((Currently Am	nended) The sensor of Claim 12, wherein said first photo-		
2		`	irst color value, said second photo-detector element produces a		
3			photo-detector element produces a third color value and said		
4	fourth photo-detector element produces a fourth color value, and further comprising:				
5	<u>-</u>		for photo-detector having a fifth photo-detector element in an		
6	elevated relation with a sixth photo-detector element, said fifth photo-detector element being				
7	electrically isolated from said sixth photo-detector element, said fifth photo-detector element				
8	being capable of designed for absorbing said blue light within said first range of wavelengths				
9	and producing a fifth color value, said sixth photo-detector element being capable of designed				
10	for absorbing said complement of blue light within said second range of wavelengths and				
11	producing a sixth color value; and				
12	i	a fourth two-c	olor photo-detector having a seventh photo-detector element in		
13	an elevated relation with an eighth photo-detector element, said seventh photo-detector				
14	element being electrically isolated from said eighth photo-detector element, said seventh				

photo-detector element being capable of designed for absorbing said complement of red light within said first range of wavelengths and producing a seventh color value, said eighth photo-detector element being capable of designed for absorbing said red light within said second range of wavelengths and producing an eighth color value.

14. (Currently Amended) A digital image sensor, comprising:

a first two-color photo-detector having a first photo-detector element eapable

of <u>designed for</u> absorbing <u>blue</u> light <u>within a first range of wavelengths</u> and a second photodetector element eapable of <u>designed for</u> absorbing <u>complement of blue</u> light <u>within a second</u>

range of wavelengths, said first photo-detector element being in an elevated relation with said
second photo-detector element;

a first dielectric layer between said first photo-detector element and said second photo-detector element;

a second two-color photo-detector having a third photo-detector element capable of designed for absorbing complement of red light within a third range of wavelengths and a fourth photo-detector element capable of designed for absorbing red light within a fourth range of wavelengths, said first, second, third and fourth range of wavelengths each being different from the other, said third photo-detector element being in an elevated relation with said fourth photo-detector element; and

a second dielectric layer between said third photo-detector element and said fourth photo-detector element.

1	15.	(Original)	The sensor of Claim 14, further comprising:			
2	a substrate, said second photo-detector element being formed within said substrate.					
1	16.	(Currently A	amended) The sensor of Claim 14, wherein said first photo-			
2	detector element is formed of amorphous silicon having a thickness selected to absorb said					
3	blue light within said first range of wavelengths and pass said complement of blue light, said					
4	second photo-detector detecting light within said second range of wavelengths passed by said					
5	first photo-detector-element.					
1	17.	(Currently A	Amended) The sensor of Claim 14, further comprising:			
2		a color filter	in an elevated relation with said first photo-detector element,,			
3	said color filte	r absorbing l	ight within another a portion of said complement of blue light			
4	range of wavelengths and passing the rest of said complement of blue light within said first					
5	and second ranges of wavelengths.					
1	18.	(Original)	The sensor of Claim 17, further comprising:			
2		a transparen	t metal conductor layer between said color filter and said first			
3	photo-detector element.					
	10	(Onininal)	The convey of Claims 14 fourther comprising:			
1	19.	(Original)	The sensor of Claim 14, further comprising:			
2		•	driving said first photo-detector element and said second photo-			
3	detector element, said first photo-detector element being in an elevated relation with said					
4	circuitry.					
1	20-26.	(Canceled).				

- 27. (Currently Amended) The sensor of Claim 1, wherein said first photo-detector element is formed of amorphous silicon having a first thickness selected to absorb said blue light within said first range of wavelengths and said third photo-detector element is formed of amorphous silicon having a second thickness selected to absorb said complement of red light within said third range of wavelengths.
- 28. (Currently Amended) The sensor of Claim 14, wherein said first photodetector element is formed of amorphous silicon having a first thickness selected to absorb

 said blue light within said first range of wavelengths and said third photo-detector element is
 formed of amorphous silicon having a second thickness selected to absorb said complement

 of red light within said third range of wavelengths.